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PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Batch No.: D42

Hideki KOMATSUDA et al.

Allowed: March 13, 2001

5/2
7-19-01
C. Church

Application No.: 09/396,582

Examiner: C. Church

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Docket No.: 105203

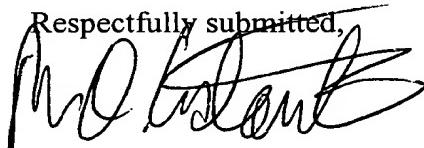
For: EXPOSURE APPARATUS AND EXPOSURE METHOD USING SAME

LETTER TO THE OFFICIAL DRAFTSPERSON

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Please substitute the attached 2 sheets of formal drawings depicting Figures 1 and 2 for the corresponding drawings filed with the application.

Respectfully submitted,


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Date: April 12, 2001

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